Application/Control No.	Applicant(s)/Patent under Reexamination
10/668,783	HIMABINDU ET AL.,
Examiner	Art Unit
Jean M. Corrielus	2162

SEARCHED				
Class	Subclass	Date	Examiner	
707	201	7/10/2005	JMC	
707	200	7/10/2005	JMC	
714	6	7/10/2005	JMC	
<del>7</del> 11	154	7/10/2005	JMC	
711	159	7/10/2005	JMC	
707	203	7/10/2005	JMC	
707	204	7/10/2005	JMC	
717	162	7/10/2005	JMC	
717	112	7/10/2005	JMC	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
	<u>.</u>				

SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
WEST	7/10/2005	JMC
NPL (IEEE,ACM)	7/10/2005	JMC
·		